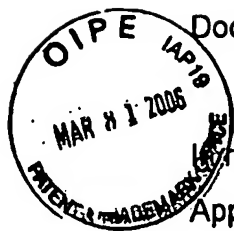


AF <sup>THW</sup>

Docket No. TIP487US

TI-36657



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Re **PATENT** application of:

Applicant: David A. Stark *et al.*

Application No.: 10/696,623

For: CHEMICAL MECHANICAL POLISHING SYSTEM

Filing Date: October 29, 2003

Examiner: Maurina T. Rachuba

Art Unit: 3723

**REPLY TO FINAL OFFICE ACTION DATED JANUARY 27, 2006**

Mail Stop AF  
Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully requested in view of the following amendments and remarks.

Do Not enter 4/6/06 AF